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RE 3,671,511 PATENT

~~THE UNITED STATES PATENT AND TRADEMARK OFFICE~~

In re Application of:
Nallan, et al.

Serial No.: 09/993,240

Filed: November 13, 2001

Confirmation No.: 6869

For: Apparatus for Controlling a Thermal Conductivity Profile for a Pedestal in a Semiconductor Wafer Processing Chamber

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

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Group Art Unit: 2835

Examiner: Unknown

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CERTIFICATE OF MAILING 37 CFR 1.8
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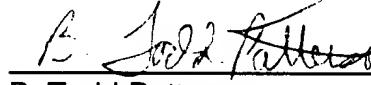
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The Filing Receipt for the above-referenced application contains an error regarding the addressee section. Please delete [3050 Bowers Avenue] from the addressee section. The addressee section should read:

Patent Counsel
Applied Materials, Inc.
P.O. Box 450A
Santa Clara, CA 95052

Attached is a copy of the Filing Receipt with the above change noted thereon.
Please correct this error or notify the applicants of the reasons for denying the request.

Respectfully submitted,


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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/993,240 ✓	11/13/2001 ✓	2835 ✓	842 ✓	6493 / ✓ ETCH / SILICON	3 ✓	21 ✓	4 ✓

CONFIRMATION NO. 6869 ✓

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Applicant(s)

- ✓ Padmapani C. Nallan, San Jose, CA; ✓
- ✓ Ajay Kumar, Sunnyvale, CA; ✓

Assignment For Published Patent Application

Applied Materials, Inc.; ✓

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted 12/04/2001

Projected Publication Date: 05/15/2003

Non-Publication Request: No

Early Publication Request: No

Title

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Apparatus for controlling a thermal conductivity profile for a pedestal in a semiconductor wafer processing chamber

Preliminary Class

361

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